

10/567488

1AP20 Res'd PCT/PTO 07 FEB 2006

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KOBAYASHI

Application No.: New U.S. National Stage of PCT/JP2004/011145

Filed: February 7, 2006

Docket No.: 126923

For: METHOD FOR PRODUCING A WAFER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of one or more non-English language reference is discussed in the present specification. See References 5-10.
- ☒ 3. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 1-4.
- ☒ 4. An English language Abstract of one or more non-English language reference is attached hereto. See References 1-10.

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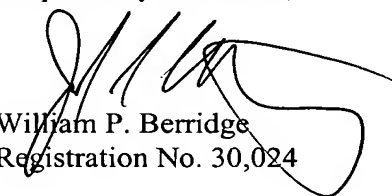
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5. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office (<http://www.jpo.go.jp>), and is attached, but has not been reviewed for accuracy. See References 1-7.

Respectfully submitted,



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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 126923		APPLICATION NO. New U.S. Patent Application 10/567488	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Takeshi KOBAYASHI			
				FILING DATE February 7, 2006			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	1.	JP A 11-322490	11/24/1999	JAPAN	X	X	
	2.	JP A 2000-211995	8/2/2000	JAPAN	X	X	
	3.	JP A 2001-53078	2/23/2001	JAPAN	X	X	
	4.	JP A 2001-77120	3/23/2001	JAPAN	X	X	
	5.	JP A 60-231365	11/16/1985	JAPAN	X	X	
	6.	JP A 61-193456	8/27/1986	JAPAN	X	X	
	7.	JP A 11-199387	7/27/1999	JAPAN	X	X	
	8.	JP A 61-193458	8/27/1986	JAPAN	X		
	9.	JP A 6-31854	2/8/1994	JAPAN	X		
	10.	JP A 6-196430	7/15/1994	JAPAN	X		
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: February 7, 2006